

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

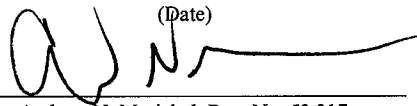
Applicant : Sherman
Appl. No. : 10/683,727
Filed : October 10, 2003
For : SEQUENTIAL CHEMICAL
VAPOR DEPOSITION
Examiner : Kelly M. Stouffer
Group Art Unit : 1762

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June 8, 2007

(Date)


Andrew N. Merickel, Reg. No. 53,317**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION WITH REQUEST FOR
CONTINUED EXAMINATION****Mail Stop AF**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted with a Request for Continued Examination and is responsive to the Final Office Action mailed on March 8, 2007. Applicant respectfully requests entry of the following amendments and consideration of the subsequent remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.